

(PTO-1449)

ATTY. DOCKET NO.
004066 USA/
Consilium/Consilium

SERIAL NO.
09/363,966

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Technology Center 2100

APPLICANT

John F. ARACKAPARAMBIL et al.

FILING DATE
July 29, 1999

**GROUP
2125**

U.S. PATENT DOCUMENTS

[illegible]

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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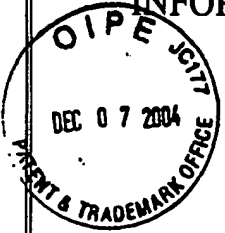
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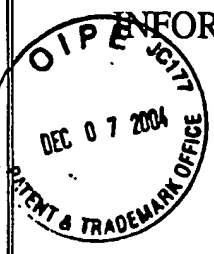
EXAMINER

DATE CONSIDERED

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 <p align="center">INFORMATION DISCLOSURE CITATION IN AN APPLICATION</p> <p align="center">(PTO-1449)</p>				ATTY. DOCKET NO. 004066 USA/ Consilium/Consilium		SERIAL NO. 09/363,966	
				APPLICANT John F. ARACKAPARAMBIL et al.			
				FILING DATE July 29, 1999		GROUP 2125	
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EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
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EXAMINER <i>Barlet</i>				DATE CONSIDERED <i>5/11/05</i>			

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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
526	September 15, 2004. Office Action for U.S. Serial No. 10/632,107, filed August 1, 2003.	
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EXAMINER	DATE CONSIDERED	
<i>Garber</i>	<i>5/11/05</i>	

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